RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 5377

Makiko KITAZOE, et al

Art Unit: 1792

Application No.: 10/591,905

Examiner: Keath T. CHEN

Filed: November 6, 2006

Attorney Docket No.: 029567-00010

For: SELF-CLEANING CATALYTIC CHEMICAL VAPOR DEPOSITION APPARATUS

AND CLEANING METHOD THEREOF

AMENDMENT FILED WITH REQUEST FOR CONTINUED EXAMINATION

MAIL STOP RCE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

December 18, 2008

Sir:

In reply to the June 19, 2008, Office Action and the November 14, 2008 Advisory Action, the period for reply being extended by the attached Petition for Extension of Time, and upon grant of the attached Request for Continued Examination (RCE). please amend the above-identified application as follows:

Amendments to the claims, as reflected in the listing of claims, being on page 2; and

Remarks begin on page 7.